

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. NIT-393	SERIAL NO.	
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>				APPLICANT K. SUZUKI et al		
				FILING DATE August 25, 2003		GROUP
<b>U.S. PATENT DOCUMENTS</b>						
* EXAMINER INITIAL	DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
DL	AL	8-329843	12/13/96	Japan	—	— <input type="checkbox"/> <input checked="" type="checkbox"/>
	AM					<input type="checkbox"/> <input type="checkbox"/>
	AN					<input type="checkbox"/> <input type="checkbox"/>
	AO					<input type="checkbox"/> <input type="checkbox"/>
	AP					<input type="checkbox"/> <input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>						
DL	AR	High-Resolution Interlaced Addressing for Plasma Displays, 1999 SID International Symposium Digest of Technical Papers, Vol. XXX, 14.1, 1999, pp. 154-157.				
DL	AS	Ultraviolet Production Efficiency of AC-PDPs and Ways to Increase It, 3rd International Conference on Atomic and Molecular Data and Their Applications ICAMDATA, AIP Conference Proceedings, Vol. 636, 2002, pp. 75-84.				
DL	AT	Theoretical formulation of the VUV production efficiency in a plasma display panel, J. Appl. Phys., Vol. 88, 2000, pp. 5605-5611.				
EXAMINER <i>Donna Lui</i>				DATE CONSIDERED <i>January 17, 2006</i>		

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.